

FORM PTO-1449 (MODIFIED)		ATTORNEY DOCKET NO.	SERIAL NO.
<p style="text-align: center;">LIST OF PATENTS AND PUBLICATIONS FOR APPLICANTS INFORMATION DISCLOSURE STATEMENT</p>		SP01-131A	
		APPLICANT Po Ki Yuen et al.	
		FILING DATE	GROUP: 1744

REFERENCE DESIGNATION		U.S. PATENT DOCUMENTS					
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date if Approp.
DK	AA	5,100,775	03-31-92	P.J. Smyczek et al.	435	6	
	AB	5,188,963	02-23-93	M.J. Stapleton	435	299	
	AC	5,346,672	09-13-94	M.J. Stapleton et al.	422	102	
	AD	5,451,500	09-19-95	M.J. Stapleton	435	6	
	AE	5,681,741	10-19-97	Atwood et al.	435	287.2	
	AF	5,922,604	07-13-99	M.J. Stapleton et al.	436	46	
	AG	6,114,122	09-2000	Besemer et al.	435	6	
	AH	6,159,727	12-12-00	D. Bochkariov	435	287.2	
	AI	6,258,593	07-2001	Schembri et al.	435	287.2	
	AJ	6,287,768	09-2001	Chenchik et al.			
	AK	6,422,249	07-2002	Certa et al.	134	168R	
	AL	2002/0150933	10-2002	Ehricht et al.	435	6	
DK	AM	2002/0061529	05-2002	Bridgham et al.	435	6	

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub-Class	Translation Yes	Translation No
	AN							
	AO							
	AP							
	AQ							

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

DK	AR	Deniz Armani et al., "Re-Configurable Fluid Circuits by PDMS Elastomer Micromachining", 12th International Conference on MEMS, MEMS 99, pp.222-227, Orlando, FL, 1998
	AS	
	AT	
	AU	
	AV	
	AW	

EXAMINER:

Paul Reddy

DATE CONSIDERED:

3/5/05

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609: draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.